

## L I S T   O F   S Y M B O L S

## PART I

A	:	area of conductor
C	:	concentration of electrolyte
c	:	intercept of line on Y-axis
$\mathcal{C}$	:	cell constant
K	:	Specific conductivity
M	:	molarity
m	:	molality
m.f.	:	mole fraction
$m_1$	:	regression co-efficient of y on X
$m_2$	:	regression co-efficient of x on Y
N	:	normality
$\eta$	:	co-efficient of viscosity; dynes-sec-cm <sup>-2</sup> or poise
r	:	correlation co-efficient
$R_x$	:	unknown resistance
$\bar{u}$	:	Average ion velocity
$V^+$	:	velocity of positive ions
$V^-$	:	velocity of negative ions
W	:	molecular weight
$\bar{X}$	:	mean (average) value
$\bar{Y}$	:	mean (average) value
$\sqrt[3]{\phantom{x}}$ <sub>m</sub>	:	co-efficient of cubical expansion of liquid
$\theta$	:	temperature in °C
d $\theta$	:	temperature difference

## PART II

A	:	Area of cross section; angle of orientation of the longer diagonal of the Knoop indentation mark measured from [100] direction.
$A_0$	:	Initial area of cross section
a	:	standard hardness (constant)
$a_0$	:	minimum value of A in the parabolic curve of H Vs. A
$A_R$	:	axis of rotation
b	:	constant
C	:	constant; constant of Indenter geometry; intercept of the plot of $\sqrt{HA}$ Vs. A
$C_1$	:	constant
$C_c$	:	calculated value of intercept using formula $C = \frac{1}{2} \sqrt{h_0 \cdot a_0}$ for straight line plot of $\sqrt{HA}$ Vs. A
$C_s$	:	Statistically determined value of the intercept of the straight line plot of $\sqrt{HA}$ Vs. A
$C_{Ar}$	:	constant for different applied loads and orientations
CRSS	:	critical resolved shear stress
d	:	diagonal length of Knoop indentation mark
$d_{Ar}$	:	length of the longer diagonal of Knoop indentation mark corresponding to different applied loads $P_r$ and orientation A
E	:	Young's modulus of elasticity
e,f	:	constant
ERSS	:	effective resolved shear stress
F	:	force; facet
$F_T$	:	tensile stress axis
$F_c$	:	compressive stress axis

$\bar{H}$	:	average hardness in high load region
HLR	:	high load region
$h_o$	:	minimum value of hardness in the parabola of $H$ Vs. $A$
$H$	:	line parallel to indenter face
ILR	:	intermediate load region
$K$	:	constant
$l$	:	length after small compression
$l_o$	:	initial length
LLR	:	low load region
$m$	:	Slope of the plot of $\log \bar{H}T_q$ Vs. $\log T_q$ ; Slope of the plot of $\sqrt{\bar{H}A}$ Vs. $A$
$m_1$	:	Slope of the plot of $\log T_q \sqrt{\bar{H}A}$ Vs. $\log T_q$
$m_A$	:	Slope of the plot of $\log T_q d$ Vs. $\log T_q$
$m_G$	:	calculated value of slope by using formula $m = \frac{1}{2} \sqrt{h_o/a_o}$ for straight line plot of $\sqrt{\bar{H}A}$ Vs. $A$
$m_s$	:	statistically determined value of the slope of the straight line plot of $\sqrt{\bar{H}A}$ Vs. $A$
$n$	:	slope of the plot of $\log d$ Vs. $\log P$
$P$	:	load in gm; constant
$P_r$	:	different applied loads
$r$	:	constant of indenter geometry
S.d.	:	slip direction
S.P.N.	:	slip plane normal
$T_q, T_Q$	:	quenching temperature °K
$W$	:	Newtonian resistance pressure
$\sigma$	:	compressive stress
$\epsilon$	:	compressive strain

$\lambda$	:	angle between tensile stress axis ( $F_T$ ) and slip direction (s.d.)
$\phi$	:	angle between tensile stress axis ( $F_T$ ) and slip plane normal (S.P.N.)
$\psi$	:	angle between an axis parallel to the indenter face (H) and the axis of rotation (AR)(normal to slip direction) of the slip system during deformation
$\sqrt{\phantom{x}}$	:	angle between the axis H (normal to F and parallel to the indenter face) and the slip direction (s.d.)

### PART III

A	:	pre-exponential factor
B	:	breadth of an etch-pit along $[1\bar{1}0]$
C	:	concentration of an etchant
$C_a$	:	acid concentration
$C_P$	:	concentration at which maxima, minima or kink occurs in various plots
D	:	diffusion rate; amount of reaction
E	:	Activation energy
$E_t$	:	Activation energy for tangential dissolution
$E_s$	:	Activation energy for surface dissolution
$E_\mu$	:	Activation energy for viscosity of the material
$E_\sigma$	:	Activation energy for electrolytic conductivity of an etchant
$E_{tL}$	:	Activation energy for tangential dissolution along length direction $[110]$
$E_{tB}$	:	Activation energy for tangential dissolution along breadth direction $[1\bar{1}0]$

$K$	:	Boltzmann constant, constant
$K_a$	:	constant
$L$	:	length of an etch-pit along $[110]$
$n$	:	concentration of charge carriers
$R$	:	universal gas constant
$S$	:	carrier charge
$T$	:	temperature $^{\circ}K$
$V$	:	rate of dissolution
$V_t, V_L$	:	lateral/tangential or ledge dissolution velocity parallel to surface
$V_n$	:	dissolution velocity normal to surface
$V_s$	:	rate of surface dissolution
$V_{nd}$	:	normal dissolution velocity at a dislocation
$V_{ndf}$	:	normal dissolution velocity of a dislocation-free portion of the surface
$V_{tL}$	:	rate of tangential dissolution along length direction $[110]$
$V_{tB}$	:	rate of tangential dissolution along breadth direction $[1\bar{1}0]$
$V_{sP}$	:	maximum surface dissolution rate
$V_{tLP}$	:	maximum tangential dissolution rate along length direction $[110]$
$V_{tBP}$	:	maximum tangential dissolution rate along breadth direction $[1\bar{1}0]$
$\mu$	:	co-efficient of viscosity of the solution
$\mu_s$	:	carrier mobility
$\sigma$	:	electrolytic conductivity of etchant
$\sigma_p$	:	electrolytic conductivity at kink of the plot of $\sigma$ Vs. $C$
$\delta$	:	desorption rate
$\delta_w$	:	desorption rate for weak reaction
$\delta_s$	:	desorption rate for strong reaction.